

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **ALBERTO OTOGURO et al.**

Group Art Unit: 1752

Serial No.: 10/092,310

Examiner: **Amanda C. Walke**

Filed: **March 7, 2002**

Confirmation No.: 8414

For: **MULTI-LAYERED RESIST STRUCTURE AND MANUFACTURING
METHOD OF SEMICONDUCTOR DEVICE**

Attorney Docket Number: **020201**

Customer Number: **38834**

AMENDMENT TRANSMITTAL

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

November 15, 2004

Sir:

Transmitted herewith is an Amendment in the above-identified application. The fee has been calculated as shown below.

| | CLAIMS REMAINING AFTER AMENDMENT | | HIGHEST NUMBER PREVIOUSLY PAID FOR | PRESENT EXTRA |
|-----------------------------------------------------------------|-------------------------------------------|-------|---------------------------------------------|------------------|
| Total (37 CFR 1.16(c)) | 20 | Minus | 20 | = 0 |
| Independent (37 CFR 1.16(b)) | 4 | Minus | 3 | = 1 |
| FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIM (37 CFR 1.16(d)) | | | | |

| SMALL ENTITY | | OR | OTHER THAN SMALL ENTITY | |
|--------------------|------------------------|----|----------------------------|------------------------|
| RATE | ADDI- TIONAL FEE | | RATE | ADDI- TIONAL FEE |
| X \$9 | | OR | X\$18 | 0.00 |
| X \$44 | | OR | X\$88 | 88.00 |
| + \$150 | | OR | + \$300 | 0.00 |
| TOTAL ADD'L FEE | | | TOTAL ADD'L FEE | 88.00 |

☒ Enclosed please find our check in the amount of \$88.00 for the additional claims fee in connection with this Amendment.

☒ The Commissioner is hereby authorized to charge payment for any additional fees associated with this communication or credit any overpayment to Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Sadao Kinashi
Sadao Kinashi

Attorney for Applicants

Registration No. 48,075

Telephone: (202) 822-1100

Facsimile: (202) 822-1111

SK/sg



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Akihiko OTOGURO et al.**

Group Art Unit: **1752**

Serial No.: **10/092,310**

Examiner: **Amanda C. Walke**

Filed: **March 7, 2002**

Confirmation No.: **8414**

For: **MULTI-LAYERED RESIST STRUCTURE AND MANUFACTURING
METHOD OF SEMICONDUCTOR DEVICE**

Attorney Docket Number: **020201**

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AMENDMENT UNDER 37 CFR § 1.116

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

November 15, 2004

Sir:

In response to the Office Action dated August 25, 2004, applicants amend the above-identified application as follows and submit the following remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

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